



**ELECTRONIC COPY**

LG728572929  
Report verification at igi.org



August 28, 2025  
IGI Report Number **LG728572929**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **EMERALD CUT**  
Measurements **17.31 X 10.87 X 7.21 MM**  
**GRADING RESULTS**  
Carat Weight **13.59 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

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**GRADING RESULTS**

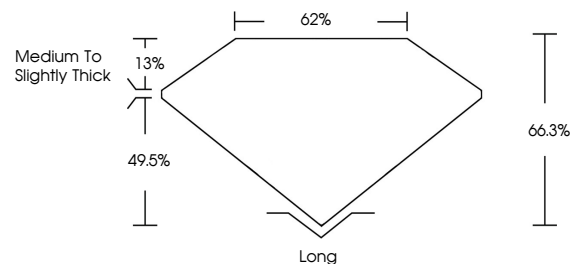
Carat Weight **13.59 CARATS**  
Color Grade **F**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG728572929**

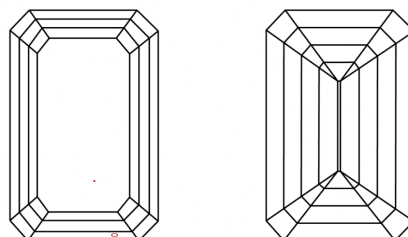
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

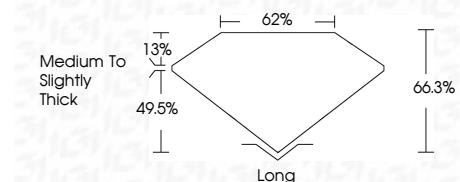
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



August 28, 2025  
IGI Report No LG728572929  
**EMERALD CUT**  
17.31 X 10.87 X 7.21 MM  
13.59 CARATS  
Color Grade **F**  
Clarity Grade **VVS 2**  
Table **66.3%**  
Girdle **62%**  
Medium to Slightly Thick  
Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG728572929**  
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